



089-11

PATENT

#38
CA
3-29-97

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yasunori INOUE et al.

Serial Number: Not Yet Assigned

Filed: August 29, 1997

For: FABRICATION METHOD OF SEMICONDUCTOR DEVICE AND ABRASIVE LIQUID USED THEREIN

CLAIM FOR PRIORITY UNDER 35 U.S.C. 119

Assistant Commissioner for Patents
Washington, D.C. 20231

August 29, 1997

Sir:

The benefit of the filing dates of the following prior foreign applications are hereby requested for the above-identified application, and the priority provided in 35 U.S.C. 119 is hereby claimed:

Japanese Appln. No. 8-230826, filed on August 30, 1996; and

Japanese Appln. No. 9-010426, filed on January 23, 1997.

In support of this claim, the requisite certified copies of said original foreign applications are filed herewith.

It is requested that the file of this application be marked to indicate that the applicants have complied with the requirements of 35 U.S.C. 119 and that the Patent and Trademark Office kindly acknowledge receipt of said documents.

In the event that any fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,
ARMSTRONG, WESTERMAN, HATTORI
McLELAND & NAUGHTON

Mel R. Quintos
Reg. No. 31,898

Atty. Docket No.: 970813
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
Tel: (202) 659-2930
Fax: (202) 887-0357
MRQ/yap

AUG 25 2003



日本国特許庁
PATENT OFFICE
JAPANESE GOVERNMENT

別紙添付の書類に記載されている事項は下記の出願書類に記載されて
る事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed
in this Office.

出願年月日
Date of Application:

1996年 8月30日
August 30, 1996

願番号
Application Number:

平成 8年特許願第230826号

願人
Applicant(s):

Pat. Appln. No. 8-230826

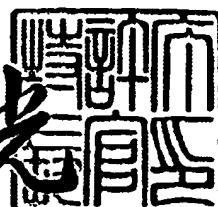
三洋電機株式会社

Sanyo Electric Co., Ltd.

1997年 5月30日
May 30, 1997

特許庁長官
Commissioner,
Patent Office

荒井 寿光
Hisamitsu ARAI



出証番号 出証特平09-3039955

Shutsu-sho-No. Shutsu-sho-toku-hei 09-3039955

BEST AVAILABLE COPY